

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: FORREST, et al. CONFIRMATION NO. 5397
SERIAL NO.: 10/581,622 GROUP ART UNIT: 1794
FILED: June 5, 2006 EXAMINER: Lawrence D. Ferguson
FOR: FREE-STANDING SILICON CARBIDE ARTICLES FORMED BY
CHEMICAL VAPOR DEPOSITION AND METHODS FOR THEIR
MANUFACTURE

ATTORNEY DOCKET NO.: 52993/326894
DATE: November 5, 2008

Commissioner for Patents
P.O. Box 1450
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CERTIFICATE OF ELECTRONIC TRANSMISSION

I hereby certify that this correspondence is being filed with the
United States Patent and Trademark Office via EFS Web on
November 5, 2008.

/lisa norris/
Lisa Norris

AMENDMENT AND RESPONSE

Sir:

In response to the Office Action of August 5, 2008, Applicants respectfully submit
the following amendments and remarks in connection with this application.

Amendments to the Claims are reflected in the listing of claims that begins on page
2 of this paper.

Remarks begin on page 5 of this paper.

The **Decision on Petition** dated July 19, 2006 is attached at the end of this paper.

Materials relating to “Moissanite-3C silicon carbide” are attached at the end of this
paper.